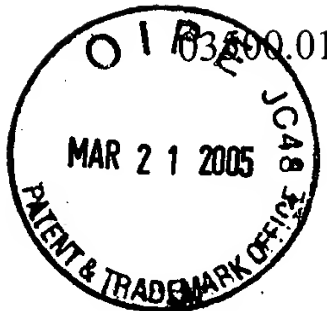


82W/762



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO)
Application No.: 09/505,627)
Filed: February 16, 2000)
For: MANUFACTURING METHOD OF)
ELECTRON BEAM APPARATUS :
AND SPACER, AND ELECTRON)
BEAM APPARATUS :
Examiner: B. Talbot
Group Art Unit: 1762
March 18, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

A. Introductory Comments

I. Applicant petitions to extend the time for response to the Office Action dated November 18, 2004 for one (1) month from February 18, 2005 to March 18, 2005. A check in the amount of \$120.00 for payment of the extension fee is enclosed.

03/22/2005 FHETEKI1 00000055 09505627
01 FC:1251 120.00 OP

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 18, 2005
(Date of Deposit)

Jason M. Okun
(Name of Attorney for Applicant)

Signature

March 18, 2005
Date of Signature

Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

II. This is in response to the Office Action dated November 18, 2004, the period for reply having been extended by the above petition and payment of the extension fee. Please amend the application as follows and consider the following remarks.